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## FACSIMILE COVER SHEET

<b>Date:</b>	<b>December 7, 2004</b>	<b>Fax:</b>	<b>703-872-9306</b>
<b>To:</b>	<b>U.S. Patent and Trademark Office</b>	<b>Phone:</b>	

**Commissioner for Patents**  
**P. O. Box 1450**  
**Alexandria, VA 22313-1450**

<b>From:</b>	<b>David C. Hsia</b>
<b>Serial No.:</b>	<b>10/779,952</b>
<b>Docket:</b>	<b>ANS-P105</b>
<b>Re:</b>	<b>Response to Restriction Requirement</b>
<b>Pages:</b>	<b>10 (including cover sheet)</b>

### Message:

Re: Applicant(s): Yee-Chung Fu  
Assignee: Advanced Nano Systems  
Title: MEMS Scanning Mirror with Trenched Surface and  
Tapered Comb Teeth for Reducing Inertia and Deformation  
Serial No.: 10/779,952  
Examiner: Allan R. Wilson  
Docket No.: ANS-P105

Filed: February 13, 2004  
Group Art Unit: 2815

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Transmittal Letter (1 page);
- (2) Response to Restriction Requirement (1 page);
- (3) Preliminary Amendment (7 pages).

The information contained in this message is intended only for the personal and confidential use of the designated recipient(s) named above. This message may be an attorney-client communication and may be protected by the work product doctrine. As such, this document is privileged and confidential. If the reader of this message is not the intended recipient, you are hereby notified that you have received this document in error and that any review, dissemination, distribution, or copying of this message is strictly prohibited. If you have received this communication in error, please notify us immediately by telephone and destroy any copies of this document in your possession. Thank you.



Brian D. Ogonowsky

Carmen C. Cook

David C. Hsia

Rachel V. Leiterman

December 7, 2004

Via Facsimile

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P. O. Box 1450  
Alexandria, VA 22313-1450

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- ☒ No additional fee is required.  
☐ The fee has been calculated as shown below:

	<u>Claims Remaining After Amendment</u>		<u>Highest No. Previously Paid For</u>		<u>Present Extra</u>	<u>Rate</u>	<u>Additional Fee</u>
Total Claims	33	Minus	42	=	0	x \$18	\$ 0.00
Independent Claims	2	Minus	3	=	0	x \$86	\$ 0.00
<input type="checkbox"/>	Fee of _____ for the first filing of one or more multiple dependent claims per application						\$
<input checked="" type="checkbox"/>	Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.						
<input type="checkbox"/>	Please charge our Deposit Account No. 502226 in the amount of						0.00
<input checked="" type="checkbox"/>	Also, charge any additional fees required and credit any overpayment to our Deposit Account No. 502226.						
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Certification of Facsimile Transmission	
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Signature	Date

Respectfully submitted,

David C. Hsia  
Attorney for Applicant(s)  
Reg. No. 46,235

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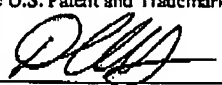
Applicant(s): Yee-Chung Fu  
Assignee: Advanced Nano Systems  
Amended Title: MEMS Scanning Mirror with Trenched Surface and Tapered Comb Teeth for Reducing Inertia and Deformation  
Serial No.: 10/779,952 Filing Date: February 13, 2004  
Examiner: Allan R. Wilson Group Art Unit: 2815  
Docket No.: ANS-P105

San Jose, California  
December 7, 2004COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, Virginia 22313-1450RESPONSE TO RESTRICTION REQUIREMENT

Dear Sir:

In response to the November 9, 2004 Restriction Requirement, Applicant selects the invention in Group I (claims 1 to 33) without traverse. Furthermore, Applicant elects species IV shown in Figs. 6A to 6J without traverse. Applicant submits that claims 1, 2, and 4 to 33 read on species IV.

In a preliminary amendment filed herewith, Applicant has cancelled the claims in Group II (claims 34 to 42). Applicant reserves the right to prosecute the cancelled claims in a divisional application. Should the Examiner have any questions, the Examiner is invited to call the undersigned at (408) 382-0480 x206.

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David C. Hsia  
Attorney for Applicant(s)  
Reg. No. 46,235